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Coupling ideality of integrated planar high-Q microresonators

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Chipscale optical microresonators with integrated planar optical waveguides are useful building blocks for linear, nonlinear and quantum optical photonic devices alike. Loss reduction through improving fabrication processes has resulted in several integrated microresonator platforms attaining quality (Q) factors of several millions. Beyond improvement of quality factor, the ability to operate the microresonator with high coupling ideality in the overcoupled regime is of central importance. In this regime the dominant source of loss constitutes the coupling to a single, desired output channel, which is particularly important not only for quantum optical applications such as the generation of squeezed light and correlated photon pairs but also for linear and nonlinear photonics. However to date, the coupling ideality in integrated photonic microresonator is not well understood, in particular design-dependent losses and their impact on the regime of high ideality. Here we investigate design-dependent parasitic losses, described by the coupling ideality, of the commonly employed microresonator design consisting of a microring resonator waveguide side-coupled to a straight bus waveguide, a system which is not properly described by the conventional input-output theory of open systems, due to the presence of higher-order modes. By systematic characterization of multi-mode high-Q silicon nitride microresonator devices, we show that this design can suffer from low coupling ideality. By performing 3D simulations, we identify the coupling to higher-order bus waveguide modes as the dominant origin of parasitic losses which lead to the low coupling ideality. Using suitably designed bus waveguides, parasitic losses are mitigated with a nearly unity ideality and strong overcoupling (i.e. a ratio of external coupling to internal resonator loss rate > 9), are demonstrated. Moreover, we find that different resonator modes can exchange power through the coupler, which therefore constitutes a mechanism that induces modal coupling, a phenomenon known to distort resonator dispersion properties. Our results demonstrate the potential for significant performance improvements of integrated planar microresonators for applications in quantum optics and nonlinear photonics, achievable by optimized coupler designs.

I. INTRODUCTION

Microresonator devices are ubiquitously used in integrated photonic circuits and enable applications that range from filters [\[1\]](#page-7-0), sensors [\[2\]](#page-7-1) and modulators [\[3\]](#page-7-2), to nonlinear applications [\[4,](#page-7-3) [5\]](#page-7-4) such as wavelength conversion [\[6,](#page-7-5) [7\]](#page-7-6) and Kerr frequency comb and soliton generation [\[8,](#page-7-7) [9\]](#page-7-8). Moreover, quantum optical experiments such as the generation of squeezed light [\[10\]](#page-7-9) and correlated photon pairs [\[11\]](#page-7-10) have also been implemented based on integrated microresonator devices. While most microresonator devices in integrated photonics are formed by single-mode waveguides [\[12,](#page-7-11) [13\]](#page-7-12), many recent photonic integrated circuits rely on multi-mode waveguides due to their lower losses [\[14,](#page-8-0) [15\]](#page-8-1), higher data capacity [\[16\]](#page-8-2), improved device integration [\[17\]](#page-8-3) and tailored dispersion properties e.g. to attain anomalous group velocity dispersion required for parametric frequency conversion [\[18,](#page-8-4) [19\]](#page-8-5). In contrast to the well-established approach of the input-output formalism of a damped quantum system [\[20\]](#page-8-6) which considers a single well-defined input and output channel, the presence of higher-order modes as output channels requires consideration.

Early research on ultra high-Q microresonators in other platforms led to the development of several adjustable evanescent coupling techniques based on prisms and tapered optical fibers [\[21–](#page-8-7)[25\]](#page-8-8). To quantitatively describe the performance of these couplers with multiple output channels, the "coupling ideality" was defined for tapered fiber coupling to microspheres, as the ratio of the power coupled from the resonator to the fundamental fiber mode divided by the total power coupled to all guided and non-guided fiber modes [\[25\]](#page-8-8). A high coupling ideality enables to operate the resonator in the strongly overcoupled regime, where the output losses are dominated by the coupling to the single desired output channel. This regime is in particular relevant for quantum optics e.g. to preserve quantum correlations of generated intra-cavity photon pairs [\[11\]](#page-7-10) and squeezed states of light [\[10\]](#page-7-9). It is thus important to avoid degradation of coupling ideality in the presence of multiple output channels.

In the context of integrated planar microresonator devices, design rules [\[26,](#page-8-9) [27\]](#page-8-10) and optimized coupler geometries [\[17,](#page-8-3) [28,](#page-8-11) [29\]](#page-8-12) have been reported. However, comparatively little attention has been paid to their coupler performance, especially with regard to the multi-mode nature of waveguides. Only few reports of coupler-induced excess losses [\[30,](#page-8-13) [31\]](#page-8-14) have been published and most integrated microresonator devices, single- or multi-mode, rely on the coupler design consisting of a simple sidecoupled straight bus waveguide with a cross section identical to the resonator waveguide.

Here we present a comprehensive investigation of integrated planar high-Q silicon nitride $(Si₃N₄)$ microres-

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onator devices with several different coupler designs. Experimental resonance characterization with sufficiently large statistics and full 3D numerical simulations allow us to unambiguously reveal the detrimental effect of nonideal coupler designs, even in the presence of statistical fluctuations of resonator properties due to fabrication variations. The commonly employed coupler design using the bus waveguide of the same cross section as the resonator is found to exhibit parasitic losses due to the modal coupling to higher-order bus waveguide modes, which can severely limit the device performance. In contrast, in the design of the multi-mode resonator coupled to a single-mode bus waveguide, we observe nearly ideal coupler performance. Finally, our simulations show that coupling between different resonator modes can originate from the coupler. This provides a novel insight into the origin of modal coupling in microresonators observed in the previous work [\[9,](#page-7-8) [32\]](#page-8-15), which leads to distortion of resonator dispersion properties.

II. ANALYTICAL DESCRIPTION OF A MULTI-MODE COUPLING SECTION

Typically the evanescent coupling of light to a microresonator is described using coupled-mode theory as a power transfer to a resonator mode at the rate $\kappa_{\text{ex},0}$ [\[23,](#page-8-16) [24,](#page-8-17) [33\]](#page-8-18). Treating the resonator in a lumped model [\[34,](#page-8-19) [35\]](#page-8-20), the coupling rate $\kappa_{\text{ex},0}$ is typically estimated using the model of coupling between two co-propagating modes in adjacent waveguides [\[36\]](#page-8-21). In contrast to the power coupling ratios of conventional directional couplers, the high-Q microresonator's low internal loss rate κ_0 requires only minute power transfer to achieve critical coupling (i.e. $\kappa_{\rm ex,0}=\kappa_0$) for which the intra-cavity power build-up is maximal. Thus the coupled modes in both the resonator and the bus waveguides can be essentially treated as independent, and *κ*ex*,*⁰ depends on the mutual modal overlap and propagation constant mismatch $\Delta\beta$ (i.e. phase mismatch) [\[1,](#page-7-0) [23,](#page-8-16) [36\]](#page-8-21). This model is widely applied as it provides a qualitative insight for most cases where coupling between only two modes is considered, neglecting the coupling to other modes.

In practice for high-Q microresonators, a commonly employed coupler design consists of a side-coupled, straight bus waveguide identical in cross section to the resonator waveguide. The cross section is chosen in order to match the propagation constants of e.g. the fundamental resonator and bus waveguide modes. However in the case of multi-mode waveguides, as found for tapered fiber coupled high-Q microspheres [\[25\]](#page-8-8), coupling between different modes has to be considered as depicted in Fig. [1\(](#page-2-0)a). Moreover, the coupler can scatter light into free space modes and recently was also identified to couple the counter-propagating, clockwise (CW) and counterclockwise (CCW), waveguide modes [\[31\]](#page-8-14), which is not considered in the present work. As a result the corresponding equations of motion for the resonator modal

Figure 1. (a) Schematic representation of the coupling rates in an integrated microresonator with multi-mode waveguides. The parasitic coupling processes of a fundamental resonator mode to higher-order bus waveguide modes are illustrated. κ_0 represents the resonator's internal loss rate and $\kappa_{\text{ex},0}$ represents the coupling rate to the fundamental bus waveguide mode. $\kappa_{\text{ex,HOM}}$ represents the coupling rate to the higherorder bus waveguide modes, which are later filtered out by the inverse taper mode converter. $\kappa_{0,n}$ represents the coupling rate to other resonator modes, while *κ*rad represents the coupling rate to free space modes. (b) Plot of the transmission T (blue) and the intra-cavity power P_{res} (red) as function of the total linewidth $\kappa/2\pi$ for the ideal ($I = 1$, dashed lines) and non-ideal $(I = 0.67,$ solid lines) case.

amplitude a_0 of frequency ω_0 in the rotating frame of the driving laser ω_L have to be extended to:

$$
\frac{d}{dt}a_0 = i\Delta_0 a_0 - \left(\frac{\kappa_0 + \kappa_{\text{ex},0} + \kappa_{\text{p}}}{2}\right) a_0
$$

$$
+ \sqrt{\kappa_{\text{ex},0}}s_{\text{in}} + \frac{i}{2} \sum_{n \neq 0} \kappa_{0,n} a_n e^{i\Delta_n t} \quad (1)
$$

Here $\Delta_0 = \omega_L - \omega_0$ and $\Delta_n = \omega_L - \omega_n$ are the frequency detunings between the driving laser with amplitude *s*in and the resonator modes a_0 and a_n . The intra-cavity field decays due to the internal loss rate κ_0 and the external coupling rate $\kappa_{\text{ex},0}$ to the fundamental bus waveguide mode. The radiation into free space modes with the rate $\kappa_{\rm rad}$ and to higher-order bus waveguide modes with the rate $\kappa_{\text{ex,HOM}} = \sum_{q\neq 0} \kappa_{\text{ex},q}$ are considered as parasitic coupling losses thus form the parasitic coupling rate $\kappa_{\rm p} =$ $\kappa_{\rm rad}$ + $\kappa_{\rm ex, HOM}$, which accelerates the intra-cavity field decay.

In addition, the modal coupling term
 $\frac{i}{2} \sum_{n \neq 0} \kappa_{0,n} a_n e^{i\Delta_n t}$ is introduced to account for the fact that the resonator mode a_0 can couple to other modes with the rate $\kappa_{0,n}$. Such modal coupling is usually considered to arise from surface roughness, but is later found to originate also from the coupler. This term is

Figure 2. Characterization of coupling ideality for the fundamental TM_{R,00} mode family of 1 THz FSR (Panels a, c) and 100 GHz FSR (Panels b, d) microresonator devices. Dots of the same color correspond to resonances of the same resonator with the color bar indicating their mutual resonator-bus distance trend. The red dashed lines indicate the trend expected for ideal coupling to resonators with the internal loss rates of $\kappa_0/2\pi = 100$ MHz (c) and $\kappa_0/2\pi = 50$ MHz (b, d). For (a), (b) and (d) the bus waveguide has the same cross section as the resonator waveguide. Panels (b) and (d) show improved ideality and achieved overcoupling through the use of a single-mode bus waveguide (b) and a pulley-style coupler (d).

only relevant if the coupled modes are simultaneously resonant. Such modal coupling causes deviations of the resonance frequencies, so called avoided modal crossings, that locally distort the resonator dispersion. At such modal crossing points the coupling to another resonator mode a_n (with total loss κ_n) effectively adds an extra contribution to the parasitic loss κ_p . However, away from the modal crossing point where only the resonator mode a_0 is resonant, the added parasitic loss is negligible. The coupling ideality *I* of the resonator mode *a*0, describing the relative strength of parasitic coupling rates, is defined according to Ref. [\[25\]](#page-8-8) as:

$$
I = \frac{\kappa_{\text{ex},0}}{\kappa_{\text{ex},0} + \kappa_{\text{p}}}
$$
 (2)

In the following the effects of coupling ideality on device performance are considered. While the scattering of light into free space modes directly represents a power loss, power coupled to higher-order modes of the bus waveguide is not necessarily lost. In most cases however, the higher-order bus waveguide modes are filtered out e.g. by inverse taper mode converters [\[37\]](#page-8-22) . Thus the measured power at the device facets only consists of the power of the bus waveguide's fundamental mode and therefore the input-output relation $s_{\text{out}} = s_{\text{in}} - \sqrt{\kappa_{\text{ex},0}} a_0$ holds and $\kappa_{\text{ex,HOM}}$ represents a parasitic loss which enlarges the resonance linewidth. On resonance $(\Delta_0 = 0)$, the device power transmission *T* and intra-cavity power *P*res as function of the coupling ideality *I* and coupling parameter $K = \kappa_{\text{ex},0}/\kappa_0$ are expressed as:

$$
T = |1 - \frac{2}{K^{-1} + I^{-1}}|^2 \tag{3}
$$

$$
P_{\rm res} = \frac{D_1}{2\pi} \cdot \frac{4}{\kappa_{\rm ex,0}(K^{-1} + I^{-1})^2} P_{\rm in}
$$
 (4)

Here $D_1/2\pi$ is the resonator free spectral range (FSR). Assuming an input power $P_{\text{in}} = |s_{\text{in}}|^2 = 1$ and a constant D_1 , Fig. [1\(](#page-2-0)b) plots both the transmission T and $\text{intra-cavity power }P_{\text{res}}$ as function of the total linewidth $\kappa/2\pi = (\kappa_0 + \kappa_{\text{ex},0}/I)/2\pi$ for the ideal $(I = 1)$ and nonideal $(I < 1)$ case, with a constant κ_0 and varying κ_{ex} ₀. The effects of the non-ideal coupling become apparent: in the case of the ideal coupling (dashed lines), the point of the full power extinction (i.e. $T = 0$, the critical coupling point) coincides with the point of the maximum intra-cavity power. This is different for the non-ideal case (solid lines), in which the parasitic losses increase linearly with the coupling rate $\kappa_{\rm p} = 0.5 \kappa_{\rm ex,0}$ in a first order approximation. More importantly the value of the maximum intra-cavity power is reduced compared to the ideal case. Due to the parasitic losses, critical coupling and overcoupling are only achieved at larger total resonator linewidth, or can not be achieved at all if $\kappa_{\rm p} > \kappa_{\rm ex,0}$. It is therefore evident that in applications exploiting the resonator's power enhancement e.g. for nonlinear photonics, device performance will improve with higher coupling ideality. Likewise, the analysis shows that linewidth measurements carried out at the critical coupling point

include possible parasitic loss channels, preventing faithful measurements of the intrinsic quality factor.

III. EXPERIMENTAL STUDY OF COUPLING IDEALITY

We experimentally study the coupling ideality for integrated $Si₃N₄$ microresonators, a widely employed platform for on-chip nonlinear photonics such as Kerr frequency comb generation [\[8\]](#page-7-7) and quantum optical experiments [\[10,](#page-7-9) [11,](#page-7-10) [38\]](#page-8-23). For microresonator platforms with adjustable couplers e.g. tapered fibers and prism couplers, changing the evanescent coupling rates allows to measure the transmission-linewidth dependence of a single resonance [\[23,](#page-8-16) [25\]](#page-8-8) and to retrieve the coupling ideality via Eq. [3.](#page-3-0) In contrast, here we study photonic chips with several microresonator devices that consist of resonator and bus waveguides, as well as inverse taper mode converters [\[37\]](#page-8-22) placed at the chip facets. The microresonator devices on each chip are identical but have varying distances between resonator and bus waveguide providing different coupling rates. In this case, coupling ideality is evaluated by analyzing the transmission-linewidth dependence of many resonances acquired for each microresonator device. By measuring several resonators with varying gap distances we overcome the variations in quality factor Q inherent to the fabrication process itself.

The waveguide core is made from silicon nitride $(Si₃N₄)$ and fully cladded with silicon dioxide $(SiO₂)$. All measured samples were fabricated on the same wafer using a photonic Damascene process [\[39\]](#page-8-24). In contrast to typical subtractive processes, this process allows for voidfree, high-aspect-ratio coupler gap fabrication, eliminating excess losses due to the presence of voids. By using lensed fibers, light is coupled efficiently (loss*<* 3dB per facet) into a single fundamental mode of the bus waveguide. Calibrated transmission traces are acquired for all devices on the chip from 1500 nm to 1630 nm with a similar method as described in Ref. [\[40\]](#page-8-25). A polarization controller is used to select and maintain a stable input polarization over the full measurement bandwidth. Resonances in each recorded device transmission trace are automatically identified and fitted using a model of a splitted Lorentzian lineshape [\[41\]](#page-8-26). The resonances are grouped into different mode families by measuring their mutual FSRs and comparing them to finite-element simulations of the device geometry.

Fig. [2](#page-3-1) compares the measured transmission-linewidth dependence of the resonator's transverse magnetic fundamental mode families (TMR*,*00) for two 1 THz FSR (Panels a, c) and two 100 GHz FSR (Panels b, d) microresonator device chips. The cross section of the resonator waveguide is $0.87 \mu m$ height, and $2 \mu m$ (100 GHz FSR) and $1.5 \mu m$ (1 THz FSR) width respectively. Each point represents a measured resonance, and the points with the same color are from the same microresonator device. Different colors denote microresonator devices

with different resonator-bus distances. The red dashed line traces out the transmission-linewidth dependence for the ideal coupling of unity ideality with a fixed internal $\log \kappa_0$.

Fig. [2\(](#page-3-1)a) shows an example of low coupling ideality: a small radius $(r \approx 23 \mu m)$, 1 THz FSR resonator coupled to a multi-mode bus waveguide of the same cross section. The measured resonances of the fundamental TMR*,*⁰⁰ mode family have GHz linewidth and low extinction (i.e. high transmission), and their measured transmission-linewidth dependence does not follow a clear trend. Due to the identical cross sections of the resonator and the bus waveguides, this coupler design could be naively assumed to provide good propagation constant match between the resonator and bus waveguide TM fundamental modes, i.e. $TM_{R,00}$ and $TM_{B,00}$. However due to the small ring radius $r \approx 23 \mu$ m, the propagation constants of the $\text{TM}_{\text{R,00}}$ and $\text{TM}_{\text{B,00}}$ modes are strongly mismatched, despite the identical waveguide cross sections.

As shown in Fig. [2\(](#page-3-1)b), also a 100 GHz FSR resonator, with a ten times larger radius ($r \approx 230 \mu m$), can have limited coupling ideality when interfaced with a straight waveguide of the same cross section. Although featuring resonance linewidths below $\kappa_0/2\pi = 30$ MHz and an average linewidth of $\kappa_0/2\pi \approx 50$ MHz, the microresonator can not be efficiently overcoupled, indicating the presence of parasitic losses.

Fig. [2\(](#page-3-1)c) and (d) present two possible coupler designs that improve coupling ideality. First, as shown in Fig. [2\(](#page-3-1)c) almost unity ideality and strong overcoupling are achieved for a 1 THz FSR microresonator coupled to a single-mode bus waveguide. The bus waveguide has a cross section of 0.6 μ m height and 0.4 μ m width due to the aspect-ratio-dependent etch rate during the preform etch [\[39\]](#page-8-24). It can thus be concluded that the main source of parasitic losses leading to the low ideality in Fig. [2\(](#page-3-1)a) originates from the coupling to higher-order bus waveguide modes. Therefore using a single-mode bus waveguide can essentially avoid this kind of parasitic losses and significantly improve coupling ideality to near unity. As a result strong overcoupling can be achieved with an external coupling rate $\kappa_{\text{ex},0}$ almost a magnitude larger then the internal losses (coupling parameter $K = \kappa_{\text{ex},0}/\kappa_0 = \kappa/\kappa_0 - 1 > 9$).

However in most cases when using a single-mode bus waveguide, though coupling ideality is improved, the propagation constants of bus and resonator fundamental modes (e.g. $TM_{B,00}$ and $TM_{R,00}$) are strongly mismatched which limits the maximum value of the coupling rate $\kappa_{\text{ex},0}$. Thus a narrow gap is needed to achieve sufficient modal overlap and a large enough coupling rate $\kappa_{\rm ex,0}$ to achieve overcoupling. For the 1 THz FSR resonator, a coupling rate $\kappa_{\text{ex},0}$ sufficient for overcoupling is achieved due to its small mode volume and low internal loss per round-trip ($\propto \kappa_0/D_1$). However for smaller FSR resonators with larger mode volumes e.g. 100 GHz FSR, overcoupling might not be achieved in the case of strong propagation constant mismatch, as fabrication processes pose limitations on the narrowest resonatorbus distance. One alternative solution for smaller FSR, larger radius resonators to achieve efficient overcoupling is to use a pulley-style coupler [\[27\]](#page-8-10). Fig. [2\(](#page-3-1)d) shows the measurement results for a 100 GHz FSR microresonators coupled with a multi-mode bus waveguide of the same cross section as the resonator but in pulley-style configuration. The comparison between the two 100 GHz FSR resonators in Fig. [2\(](#page-3-1)b) and Fig. [2\(](#page-3-1)d) reveals an improved coupling ideality for the pulley-style coupler. The improved coupling ideality of the pulley-style coupler is not as high as in the case of the 1 THz FSR resonator coupled to a single-mode bus waveguide in Fig $2(c)$. However such a comparison neglects the large difference in resonator mode volume. In fact the fundamental $\text{TM}_{\text{R,00}}$ mode of the present 100 GHz FSR resonator can not be overcoupled using a single-mode bus waveguide, as the strong propagation constant mismatch limits the achievable coupling rates.

IV. SIMULATIONS OF COUPLING IDEALITY

In order to verify the dominant origin of parasitic losses and the observed strong design-dependence of coupling ideality, we implement full 3D finite-difference timedomain (FDTD) simulations [\[42\]](#page-8-27) (*Lumerical FDTD Solutions*). This allows to study numerically the light propagation through the coupler by solving Maxwell's equations in the time domain. The simulation model is shown in Fig. $3(a)$. Considering the designs of the microresonator devices experimentally characterized in the previous section, the resonator and the bus waveguide have the same cross sections, which is 1.5×0.87 μ m² (width×height) for the 1 THz FSR resonator and $2.0 \times 0.87 \ \mu \text{m}^2$ for the 100 GHz FSR resonator. The sidewall angle is $\alpha = 90^\circ$ and the resonator-bus gap distance is set as $0.5 \mu m$. A graded mesh of rectangular cells with the maximum cell volume of $(22 \text{ nm})^3$ is applied to the simulation region. The boundary condition enclosing the full simulation region is set as perfectly matched layer (PML) [\[43\]](#page-8-28), to absorb the incident light to the boundary and thus to prevent back-reflection.

The resonator fundamental TMR*,*⁰⁰ mode at the center wavelength of 1550 nm is launched with unity power and the light field propagates until the field distribution reaches the stationary state in the full simulation region. Monitors M0, M1 and M2 record the field distributions in their individual monitor planes. Fig. [3\(](#page-5-0)b) and (c) show the field distributions recorded by M0 and M1 for the resonators of 100 GHz and 1 THz FSR, respectively. An interference pattern in the field distribution along the bus waveguide is observed in both cases, and is more prominent in the case of 1 THz FSR. The field distributions recorded by M1 show that: (1) in the case of 100 GHz FSR, the field propagates predominantly in the bus waveguide fundamental TM_{B,00} mode, which indicates a

Figure 3. FDTD simulations of waveguide coupling for 100 GHz and 1 THz FSR resonators. (a) Schematic representation of the simulation model. The resonator and the bus waveguide (both in gray) have the same cross sections $(2.0 \times 0.87 \mu m^2)$ for 100 GHz FSR and $1.5 \times 0.87 \ \mu \text{m}^2$ for 1 THz FSR), the sidewall angle $\alpha = 90^{\circ}$ and are separated by 0.5 μ m gap. The boundary condition (thick black lines) enclosing the simulation region is set as PML. The resonator fundamental TMR*,*⁰⁰ mode is launched into the resonator waveguide and the monitors M0, M1 and M2 record the field distributions in their individual planes. (b), (c) The field distributions recorded by M0 and M1 for the 100 GHz and 1 THz FSR resonators. The TM_{R,00} mode is coupled not only to the bus waveguide's fundamental TM_{B,00} mode but also to its higher-order TM_{B,10} mode. The propagation constant difference of both bus waveguide modes causes the interference pattern visible along their propagation direction. This indicates degraded coupling ideality, which is more prominent in the case of 1 THz FSR. The color bar denotes the field intensity in logarithmic scale.

limited, non-unity coupling ideality; (2) while in the case of 1 THz FSR, a significant portion of power is coupled to the higher-order $TM_{B,10}$ mode that beats with the TM_{B,00} mode along the propagation in the bus waveguide, which indicates a lower coupling ideality. These qualitative conclusions from Fig. [3](#page-5-0) agree well with the experimental observation that the 1 THz FSR resonator in Fig. [2\(](#page-3-1)a) shows higher parasitic losses thus a lower coupling ideality compared to the 100 GHz FSR resonator in Fig. $2(b)$.

We perform further analysis to quantify the degradation of coupling ideality in the 1 THz FSR resonators. The total power *P*(total) coupled into the bus waveguide can be obtained by calculating the Poynting vector normal to the monitor plane of M1. In addition, using the "Mode Expansion Function" (MEF) of *Lumerical FDTD Solutions*, the field distribution recorded by M1 can be projected on each waveguide eigenmode and their individual power $(>10^{-12})$ can be calculated. All powers are normalized as they derive from the resonator fundamental TMR*,*⁰⁰ mode that is launched with unity power. The respective coupling rates $\kappa_{\text{ex},i}$ follow by re-

No.		2	3	$\overline{4}$	5	6	7
FSR	1 THz	1 THz	1 THz	1 THz	1 THz	100 GHz	100 GHz
$w_{\text{res}} \times h_{\text{res}} \ (\mu m^2)$	1.5×0.87	1.5×0.87 1.5×0.87		1.5×0.87	1.5×0.87	1.5×0.87	2.0×0.87
$w_{\text{bus}} \times h_{\text{bus}} \ (\mu \text{m}^2)$		1.5×0.87	1.5×0.87		1.5×0.87 0.40 \times 0.60 (SM)	1.5×0.87	2.0×0.87
gap (μm)	$\overline{}$	0.5	0.2	0.5	0.5	0.5	0.5
α	90°	90°	90°	80°	90°	90°	90°
$P(\text{TM}_{\text{R},10})$		1.28×10^{-4} 7.87×10^{-4} 0.0116		7.6×10^{-4}	3.9×10^{-4}		1.82×10^{-6} 1.72×10^{-5}
$P(TE_{R.00})$	$< 10^{-12}$	$< 10^{-12}$		$< 10^{-12}$ 1.08×10^{-6}	$< 10^{-12}$	$< 10^{-12}$	$< 10^{-12}$
$P(\text{TM}_{\text{B},00})$		3.36×10^{-3}	0.0344	3.31×10^{-3}	3.92×10^{-4}	0.0237	5.73×10^{-3}
$P(\text{TM}_{B,10})$		0.0176	0.0974	0.0173			3.4×10^{-6} 1.81×10^{-4}
$P(TE_{B,00})$		$< 10^{-12}$	$< 10^{-12}$	4.89×10^{-6}	$< 10^{-12}$	$< 10^{-12}$	$< 10^{-12}$
$P({\rm total})$		0.0209	0.133	0.0203	3.92×10^{-4}	0.0237	5.92×10^{-3}
		0.161	0.259	0.161	1.00	1.00	0.968

Table I. Table of simulated coupled powers for different coupler designs. The resonator fundamental TM_{R,00} mode is launched with unity power. The individual modal powers in the resonator and the bus waveguides after the coupling section are listed. For every simulated case the resonator FSR, the cross section of the resonator and the bus waveguides, the gap distance and the sidewall angle are listed. *P*(total) is the total power recorded in the bus waveguide after the coupling section and *I* is the coupling ideality calculated as $I = P(\text{TM}_{B,00})/P(\text{total})$. The bus waveguide is single-mode (SM) in the case No. 5, while all the other bus waveguides are multi-mode. Modes which do not exist are marked with hyphen " - ".

lating the coupled power to the resonator FSR $(D_1/2\pi)$ by $\kappa_{\text{ex},i} = D_1 \times P(i)$. The fundamental bus waveguide mode's power $P(\text{TM}_{B,00})$ can be obtained and the coupling ideality can thus be approximately estimated as $I = P(\text{TM}_{\text{B,00}})/P(\text{total})$, assuming that the coupling to the higher-order bus waveguide modes $(\kappa_{\text{ex,HOM}})$ is the dominant origin of parasitic losses. In addition, in order to investigate how the resonator mode is affected by the coupler, also the field distribution recorded by M2 in the resonator waveguide after the coupling section is decomposed into individual modes.

Table [I](#page-6-0) compiles the simulation results of different coupler designs (No. 1-7) with varying geometrical parameters, including the resonator FSR, the cross sections of the resonator and the bus waveguides, the gap distance, and the waveguide sidewall angle α . This angle α takes into account the fact that the fabricated waveguides have slanted sidewalls ($\alpha \approx 80^{\circ}$). For each design we calculate the individual power of the selected eigenmodes in the resonator $(TM_{R,10}$ and transverse electric fundamental resonator mode $TE_{R,00}$) and the bus waveguide ($TM_{B,00}$ $, TM_{B,10}$ and $TE_{B,00}$, and numerically compute the coupling ideality *I*.

First, Table [I](#page-6-0) shows that the commonly employed coupler design of a straight bus waveguide coupling to a resonator waveguide of the same cross section, has a higher coupling ideality for the 100 GHz FSR resonators (No. 7, $I \approx 0.968$) than for the 1 THz FSR resonators (No. 2, $I \approx 0.163$). This agrees well with the previously discussed observations in Fig. [2](#page-3-1) and Fig. [3.](#page-5-0) The degraded ideality in the case of 1 THz FSR resonators illustrates the limited applicability of this coupler design. The fact that the resonator radius strongly affects coupling ideality is more directly seen by comparing the cases No. 2 and 6, as both cases have exactly the same geometrical parameters except for the resonator FSR.

In addition, the coupling ideality of 100 GHz FSR resonators (No. 6 and No. 7) depends also on the waveguide width when coupled to a bus waveguide of the same cross section. The degradation of coupling ideality in the case No. 7 is due to more power coupled to the higherorder bus waveguide mode $(TM_{B,10})$ which can be explained with the smaller propagation constant mismatch between the fundamental resonator mode (TMR*,*00) and the higher-order bus waveguide mode $(TM_{B,10})$. Additionally the wider waveguide cross section reduces the mutual modal overlap between the fundamental TMR*,*⁰⁰ and TM_{B,00} modes and thus their mutual power transfer $P(\text{TM}_{\text{B,00}})$. Furthermore, our simulations verify the experimentally observed improvement of coupling ideality for the 1 THz FSR resonator coupled to a singlemode bus waveguide (No. 5, $I \approx 1.00$). However this is achieved at the expense of reducing power transfer to the bus waveguide $P(\text{TM}_{B,00})$ by nearly one order of magnitude, which is due to the propagation constant mismatch between the $TM_{B,00}$ and $TM_{R,00}$ modes.

Second, though only the fundamental TMR*,*⁰⁰ mode is launched in the resonator, a non-zero power in a higherorder mode $(P(TM_{R,10}))$ is recorded by M2. In addition, it is observed by comparing the uncoupled (No. 1) and coupled cases (No. 2, 3) that this power in the higher-order resonator mode power $P(\text{TM}_{R,10})$ increases with decreasing gap distance. In the case of the uncoupled resonator (No. 1), the appearance of $P(\text{TM}_{R,10}) = 1.28 \times 10^{-4}$ is mainly attributed to the mesh which acts as a $(22 \text{ nm})^3$ surface roughness at the material interface. Such surface roughness is well known to lead to modal coupling e.g. the coupling between the resonator modes TMR*,*⁰⁰ and TMR*,*10. In addition, compared with the 100 GHz FSR resonator (No. 6, 7), this effect is more prominent in the 1 THz FSR resonator (No. 1). Nevertheless for the coupled resonators (No. 2, 3), the enhancement of $P(\text{TM}_{R,10})$ with decreasing gap distance unambiguously reveals the existence of a coupler-induced modal coupling. This is an important finding revealing a novel origin of modal coupling [\[32\]](#page-8-15) in microresonators, which causes distortion of microresonator dispersion properties.

Third, the coupling of the launched TMR*,*⁰⁰ mode to the modes with the orthogonal polarization, i.e. $TE_{R,00}$ in the resonator and $TE_{B,00}$ in the bus waveguide, is observed in the case of slanted waveguide sidewalls (No. 4). Such a cross-polarization coupling occurs if the modal field distribution is asymmetric with respect to its center [\[44,](#page-8-29) [45\]](#page-8-30) and its strength depends on the degree of this asymmetry. In the simulated case, the asymmetry is introduced by the ring bending and the $\alpha = 80^{\circ}$ sidewall angle. However by comparing the cases No. 2 and 4, the sidewall angle $\alpha = 80^\circ$ only enhances significantly the power $P(\text{TE}_{R,00})$, while the powers of other modes as well as the coupling ideality remain almost the same.

V. CONCLUSION

In summary we presented the first study of coupling ideality of monolithically integrated high-Q $Si₃N₄$ microresonator devices. For the commonly employed coupler design where both the resonator and the bus waveguides have the same cross sections, we revealed the presence of parasitic losses due to the coupling to higher-order bus waveguide modes. This degrades coupling ideality which is shown both through systematic experimental characterization of resonances and full 3D FDTD simu-

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lations. Consequently, an optimized coupler design using a single-mode bus waveguide with efficiently mitigated parasitic losses (ideality $I \approx 1$) and achieved strong overcoupling $(K > 9)$ was demonstrated. Moreover we discovered that the coupler waveguide can induce modal coupling between different resonator modes which is frequently observed in high-Q microresonators.

For microresonator devices based on multi-mode waveguides, coupling ideality is non-trivial to analyze and strongly depends on coupler designs and target mode families. State-of-the-art microresonator devices for applications typically operate around the critical coupling point or the overcoupled regime, thus high device performance requires optimized coupler designs with low parasitic losses and high coupling ideality. Our study not only reveals the design-dependent coupling ideality for integrated microresonator devices but also demonstrate the importance of anticipating coupling ideality in device design and the significant improvements it can unlock. The ability to strongly overcouple planar integrated photonic resonators will in particular benefit quantum optical and nonlinear photonic experiments.

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